APR 3 0 2002

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CELLE INITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s):

H. MAEJIMA ET AL.

Serial No.:

09/704,529

Filed:

November 3, 2000

For:

WAFER HAVING CHAMFERED BEND PORTIONS IN THE JOINT REGIONS BETWEEN THE CONTOUR OF THE WAFER AND THE CUT-AWAY PORTION

OF THE WAFER

Art Unit:

2823

Examiner:

L. Pham

<u>AMENDMENT</u>

Assistant Commissioner of Patents Washington, D.C. 20231

April 30, 2002

Sir:

The following amendments and remarks are submitting in the above-identified application in response to the Office Action mailed November 30, 2001.

IN THE CLAIMS

Please cancel claims 1, 2 and 4-13.

Please add new claims 14-44 as follows.

A process for producing a semiconductor device, comprising:

providing a wafer for forming an integrated circuit thereon, the wafer having a main surface on which an integrated circuit is to be formed, a

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